

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Chow et al	Group Art Unit: 1746
Serial No: 09/362,924	Examiner: Allan Olsen
Filed: July 27, 1999	Attorney Docket No: 001945 USA P02/ETCH/SILICON/JB
Title: MULTIPLE STAGE PROCESS FOR CLEANING PROCESS CHAMBERS	December 17, 2001 San Francisco, California

AMENDMENT UNDER 37 C.F.R. § 1.111

Box Fee Amendment
Commissioner for Patents
Washington, D.C. 20231

Examiner Olsen:

This communication is filed in response to the Office Action mailed on August 15, 2001, and is filed within four months thereof with an accompanying fee for a one month extension of time.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

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By Rowena Montoya
Rowena Montoya

Dated 17 December 2001

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